

Notice of References Cited		Application/Control No. 10/529,732	Applicant(s)/Patent Under Reexamination DE VAAN, ADRIANUS JOHANNE	
		Examiner Andrew Kong	Art Unit 2851	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,631,996	10-2003	Moench et al.	353/85
*	B	US-2003/0011751	01-2003	Sakata et al.	353/30
	C	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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